L Number	Hits	Search Text	DB	Time stamp
1	108981	buried	USPAT; US-PGPUB; JPO	2004/09/19 16:13
2	5541	p-well$1 same n-well$1	USPAT; US-PGPUB; JPO	2004/09/19 16:14
3	21222	well$1 with (conductivity)	USPAT; US-PGPUB; JPO	2004/09/19 16:15
4	155371	(potential or voltage$1) near2 differen$3	USPAT; US-PGPUB; JPO	2004/09/19 16:16
5	1122235	semiconduct$3 or silicon	USPAT; US-PGPUB; JPO	2004/09/19 16:17
6	164757	implant$3	USPAT; US-PGPUB; JPO	2004/09/19 16:17
7	4006	buried and ((p-well$1 same n-well$1) or (well$1 with (conductivity))) and (semiconduct$3 or silicon)	USPAT; US-PGPUB; JPO	2004/09/19 16:17
8	576	(buried and ((p-well$1 same n-well$1) or (well$1 with (conductivity))) and (semiconduct$3 or silicon)) and implant$3 and ((potential or voltage$1) near2 differen$3)	USPAT; US-PGPUB; JPO	2004/09/19·16:18
9	4319	third adj2 well$1	USPAT; US-PGPUB; JPO	2004/09/19 16:19
10	5	((buried and ((p-well$1 same n-well$1) or (well$1 with (conductivity))) and (semiconduct$3 or silicon)) and implant$3 and ((potential or voltage$1) near2 differen$3)) not "10"	USPAT; US-PGPUB; JPO	2004/09/19 16:20
11	42	((buried and ((p-well$1 same n-well$1) or (well$1 with (conductivity))) and (semiconduct$3 or silicon)) and implant$3 and ((potential or voltage$1) near2 differen$3)) and (third adj2 well$1)	USPAT; US-PGPUB; JPO	2004/09/19 16:24
12	534	((buried and ((p-well$1 same n-well$1) or (well$1 with (conductivity))) and (semiconduct$3 or silicon)) and implant$3 and ((potential or voltage$1) near2 differen$3)) not (((buried and ((p-well$1 same n-well$1) or (well$1 with (conductivity))) and (semiconduct$3 or silicon)) and implant$3 and ((potential or voltage$1) near2 differen$3)) and (third adj2 well$1))	USPAT; US-PGPUB; JPO	2004/09/19 16:24

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